

JPW



PATENT
Customer No. 22,852
Attorney Docket No. 08244.0009-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Ki-Seon PARK et al.) Group Art Unit: 2813
)
Application No.: 10/728,855) Examiner: Smoot, Stephen W.
)
Filed: December 8, 2003) Confirmation No. 9300
)
For: METHOD FOR MANUFACTURING)
A SEMICONDUCTOR DEVICE)
FOR USE IN A MEMORY CELL)
THAT INCLUDES FORMING A)
COMPOSITE LAYER OF)
TANTALUM OXIDE AND)
TITANIUM OXIDE OVER A)
BOTTOM CAPACITOR)
ELECTRODE (AS AMENDED))

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Ex parte Quayle Action mailed June 20, 2005, the period for response to which extends through August 22, 2005 (August 20, 2005 being a Saturday), please amend the above-identified application as follows:

An Amendment to the Specification is reflected on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims beginning on page 3 of this paper.

Remarks follow the **Amendment to the Claims** section and begin on page 8 of this paper.